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		Application Number	10/585,175
		Filing Date	July 6, 2007
		First Named Inventor	Simon BLÜMEL
		Art Unit	2812
		Examiner Name	SENE, Pape A.
Sheet 1 of 1	Attorney Docket Number	5367-249PUS	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind-Code <sup>2</sup> (if known)			
		US-4,610,746	09-09-1986	Broer et al.	
		US-5,403,978	04-04-1995	Drabek et al.	
		US-2003/0116769	06-26-2003	Song et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind-Code <sup>5</sup> (if known)				
		JP 06-218627	08-27-1993	Rudorufu et al.		Abstr.
		JP 2003-234008	08-22-2003	Nakanishi et al.		Abstr.
		JP 60-087306	05-17-1985	Deiruku et al.		
		TW 479378	03-11-2002	Li Jr-Feng, et al.		Abstr.
		TW 495936	07-21-2002	Chen Shing et al.		Abstr.
		TW 527017	04-01-2003	Chen Hsing et al.		

Examiner Signature	/Pape Sene/	Date Considered	12/09/2010
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